

Notice of References Cited	Application/Control No. 10/790,871	Applicant(s)/Patent Under Reexamination TATEIWA, AKIHIKO	
	Examiner James D. Stein	Art Unit 2874	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0085807	07-2002	Xiaofan, Zhu	385/33
*	B	US-2002/0141705	10-2002	Duelli et al.	385/49
*	C	US-5,953,477	09-1999	Wach et al.	385/115
*	D	US-2005/0084206	04-2005	Gutin et al.	385/024
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
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FOREIGN PATENT DOCUMENTS

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	N					
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	P					
	Q					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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